



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DeLoach et al. Art Unit: 2822
Serial No.: 10/703,387 Examiner: Thomas, T.
Filing Date: 11/06/2003 Docket No.: TI-35862
Customer No.: 23494 Conf. No.: 9996
Title: FORMING A TRENCH TO DEFINE ONE OR MORE ISOLATION
REGIONS IN A SEMICONDUCTOR STRUCTURE

LETTER OF TRANSMITTAL


Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being
deposited with the U.S. Postal Service as First Class Mail
in an envelope addressed to: Commissioner of Patents,
P.O.Box 1450, Alexandria, VA 22313-1450.

Date

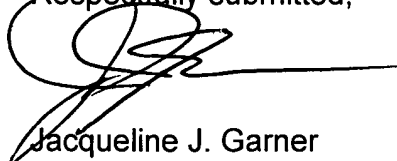
4-21-05


Marianna Smith

Enclosed please find the signed Supplemental Declarations in the above-identified application.

Please charge any necessary fee to Deposit Account No. 20-0668.

Respectfully submitted,


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